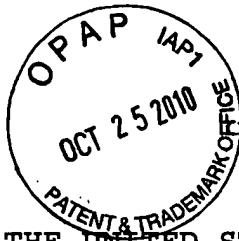


KANEKO.014AUS



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Minoru Umemoto et al.) Group Art Unit
Serial No. : 10/585,707)
Filed : July 10, 2006)
For : PROCESS OF FORMING)
ULTRAFINE CRYSTAL LAYER,)
MACHINE COMPONENT HAVING)
ULTRAFINE CRYSTAL LAYER)
FORMED BY THE ULTRAFINE)
CRYSTAL LAYER FORMING)
PROCESS, PROCESS OF)
PRODUCING THE MACHINE)
COMPONENT, PROCESS OF)
FORMING NANOCRYSTAL LAYER,)
MACHINE COMPONENT HAVING)
NANOCRYSTAL LAYER FORMED)
BY THE NANOCRYSTAL LAYER)
FORMING PROCESS, AND)
PROCESS OF PRODUCING THE)
MACHINE COMPONENT)
Examiner : Christopher S. Kessler)

AMENDMENT

Hon. Commissioner
of Patents and Trademarks
Alexandria, VA 22313-1450

Dear Sir:

This amendment is submitted for the above-identified patent application in response to the office action from the United States Patent and Trademark Office mailed July 9, 2010. Please make the following election and changes: